

# FEATURED ALUM-A-LIFT SEMICONDUCTOR LITHOGRAPHY INSPECTION LIFT

## PROJECT 32632

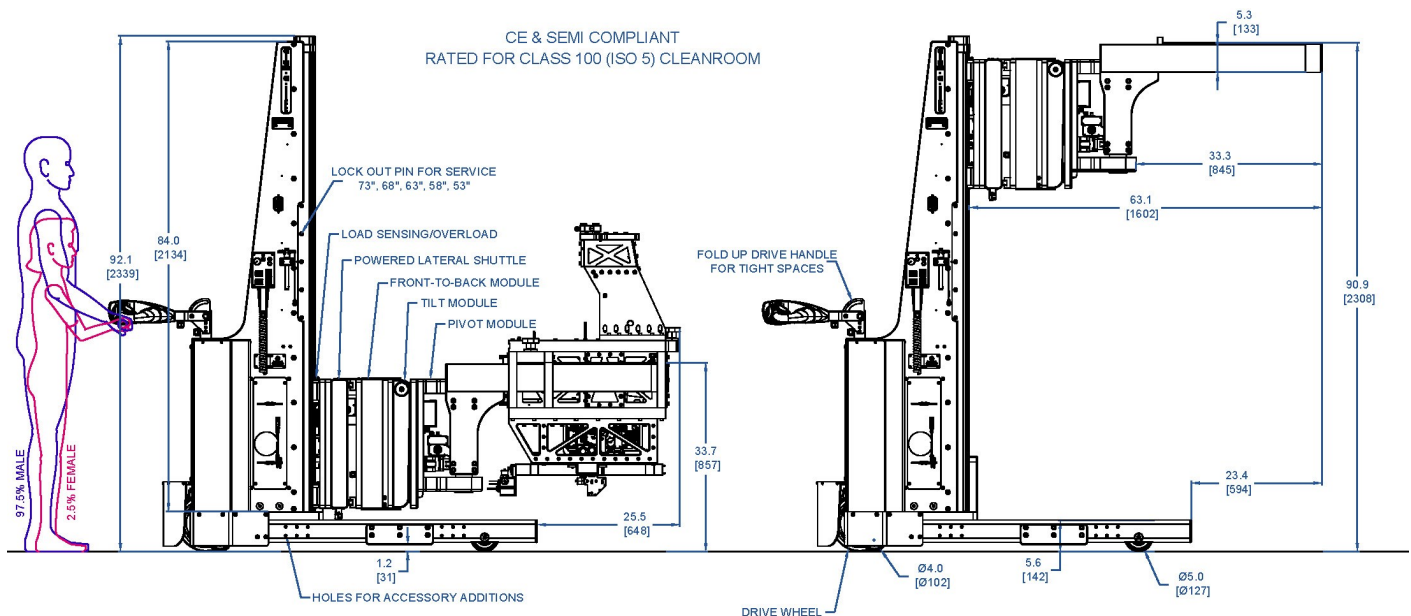


**MODEL** A3500CRCSLRPD-84

**FEATURING** Lined Stainless Steel Fork Set, Powered Yaw and Pivot Rotation, Powered Front to Back Shuttle, Powered Lateral Shuttle, Laser Optical Alignment, Obstacle and Overload Sensing, Powered Drive Wheel, ISO 5 (Class 100 Cleanroom Rated, SEMI S2, CE Compliant

**HANDLING** 1660 lb [753 kg] Inspection Assemblies

**DETAILS** Designed for a global leader in nanometer-scale lithography defect inspection systems catering to semiconductor chip manufacturing, this lift system can perform detailed installation and maintenance operations with precise, repeatable placement of a heavy imaging component. The distinctive feature of this lift lies in its capacity to deliver powered movements with a remarkable resolution of under 100 microns, surpassing client expectations.



**alum-a-lift**

13941 Veterans Memorial Hwy  
Winston, GA 30187 USA  
+1 770 489 0328

GET STARTED AT [ALUM-A-LIFT.COM](http://ALUM-A-LIFT.COM)